



ELECTRONIC COPY

LG779620768
Report verification at igi.org



March 6, 2026

IGI Report Number **LG779620768**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **9.48 X 6.53 X 3.93 MM**

GRADING RESULTS

Carat Weight **1.49 CARAT**

Color Grade **F**

Clarity Grade **VVS 2**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

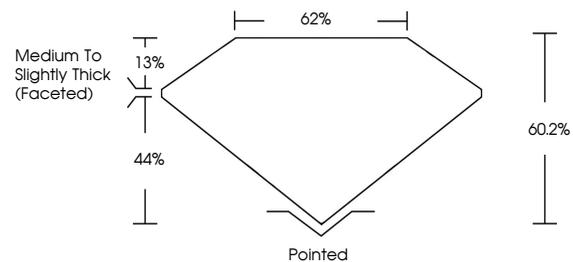
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG779620768**

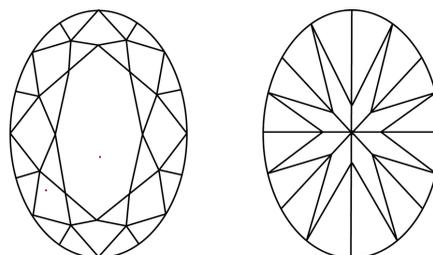
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

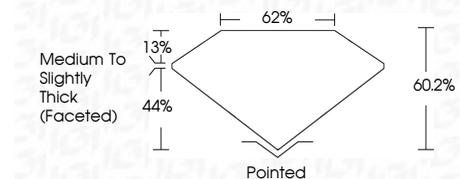
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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Fluorescence **NONE**

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IGI



March 6, 2026
IGI Report No LG779620768
OVAL BRILLIANT
9.48 X 6.53 X 3.93 MM
Carat Weight 1.49 CARAT
Color Grade F
Clarity Grade VVS 2
Depth 44%
Table 13%
Girdle Medium to Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG779620768
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa